



# Introduction to EELS data analysis

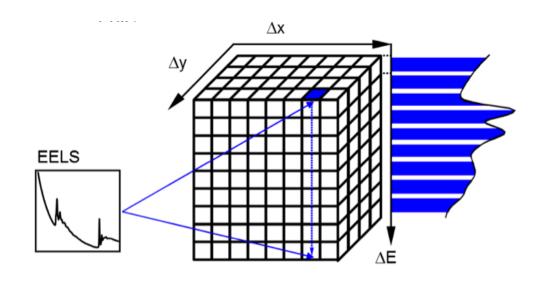
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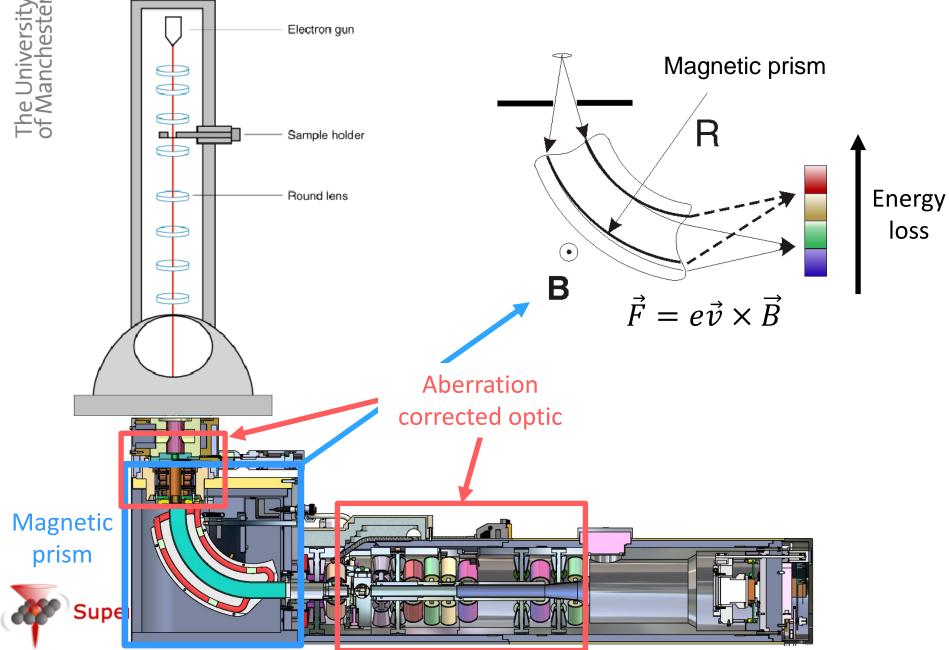


- Introduction to EELS
- Elemental quantification
  - Integration method
  - Curve fitting method





# EELS measures the energy that electrons have lost in the specimen



- Core-loss edges can be used to estimate the elemental composition of the specimen
- Low loss contains plasmon, phonon, band gap, etc.

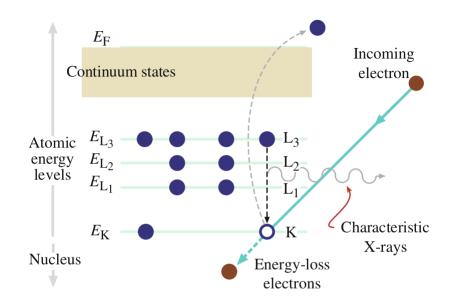


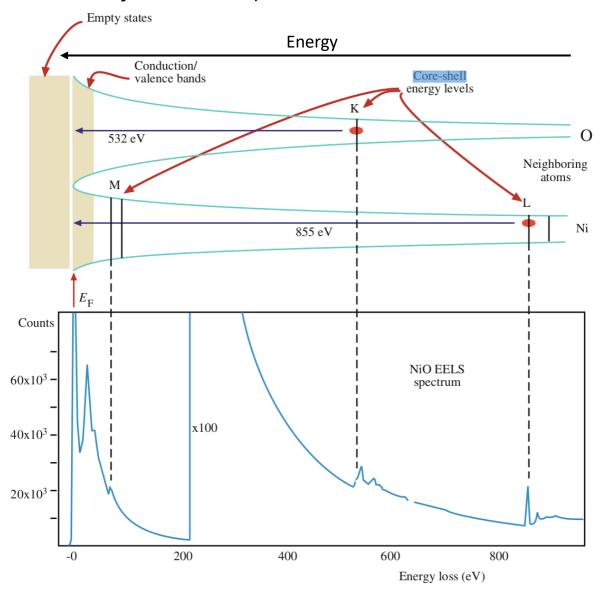
FIGURE 4.2. The ionization process. An inner (K) shell electron is ejec-Plasmon ted from the atom by a high-energy electron. When the hole in the K shell Phonon is filled by an electron from the L shell, characteristic  $(K_{\alpha})$  X-ray emission occurs. The beam electron loses energy but continues on through the Zero-loss peak 1.0 specimen. Intensity x 5.96e+05 (counts) Core loss CK $Mn L_{2,3}$ 800x 3 Low loss  $\text{Ge } L_{2.3}$ 0.0 200 400 600 800 1000 1200 1400 Energy loss (eV) Williams and Carter, TEM, Springer (2009)

EELS maps empty states above the Fermi level

Low-loss region is from plasmon excitation. Lies at energy level of conduction / valence bands

Ionization results in electrons which are ejected from core states into empty states above the Fermi level

This is why these are 'edges', and not 'peaks' - there is an onset

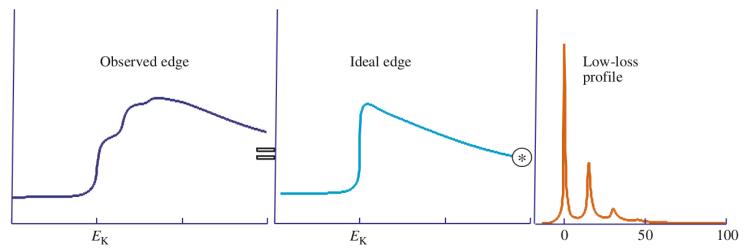


**FIGURE 39.6.** The correspondence between the energy levels of electrons surrounding adjacent Ni and O atoms and the energy-loss spectrum. The deeper the electrons sit in the potential well the more the energy needed to eject them. The ZLP is above the Fermi energy  $E_F$ , the plasmon peak is shown at the energy level of the conduction/valence bands where plasmon oscillations occur in the loosely bound electrons. The critical ionization energy required to eject electrons in specific shells is shown (Ni L: 855 eV and O K: 532 eV).



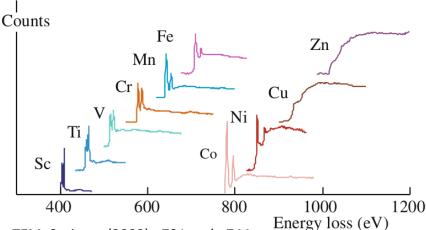
How does an edge generally looks like? Well, it depends on a few things...

- On the thickness of your specimen
  - Plural scattering in thick specimen changes background
  - Core-loss scattering followed by plasmon scattering ⇒ Convolution of the edge feature with the plasmon peak



It also depends on the band structure of your materials Some element are know to have sharp peak called "white line"

**FIGURE 40.4.** Spectra from the transition metals show a variation in the  $L_3$  and  $L_2$  white-line intensity ratios reflecting the variation in the number of core L-shell electrons ejected into unfilled d states. Note that Cu and Zn show no white lines because their d shells are full. The  $L_3$  and  $L_2$  white lines in the Fe L edge are the only ones that show the expected  $L_3$ : $L_2$ 



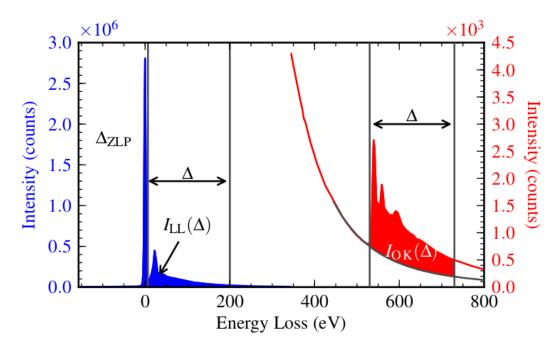


### Elemental analysis of EELS spectrum

# The University of Manchester

- EELS can be used to estimate the relative composition of a specimen
  - Similar to EDS
- Integration method
- Subtract the background by extrapolation (usually, we use a power-low)
- 2. Integrate the number of count  $I_K$  in the edge within a limited energy range after the edge onset
- 3. Compute the cross-section  $\sigma_K$  for this specific experimental conditions based on theoretical model; alternatively use own calibrated experimental factors

$$\frac{C_A}{C_B} = \frac{I_K^A}{I_K^B} \frac{\sigma_K^A}{\sigma_K^B}$$



de la Peña (2010) PhD thesis

### Integration method

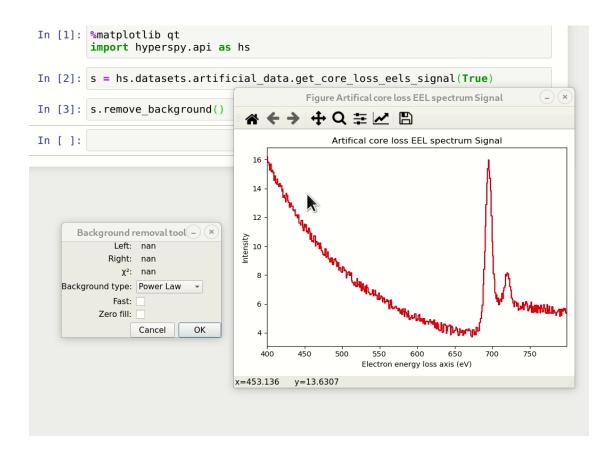


# Advantage

- Fast
- Simple

# **Drawback**

- Background extrapolation inaccuracy
- User bias: where should the windows be?
- Issue when edges are overlapping
- Plural scattering needs to be removed





# Curve fitting method

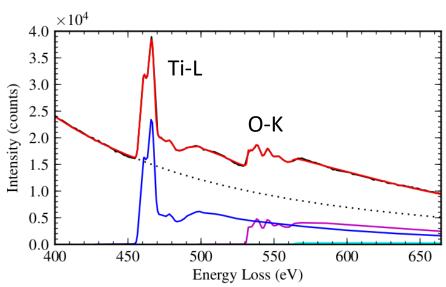


- Model
  - Combination of functions describing the spectrum
  - Noise model
  - Set of initial parameters
- Non-linear fitting
  - Optimise parameters

A typically EELS model to quantify elemental composition

consists of

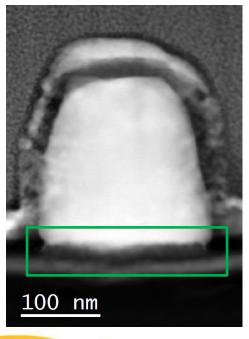
- A power background
- Core-loss edge
- Convolution with low-loss spectrum to model plural scattering

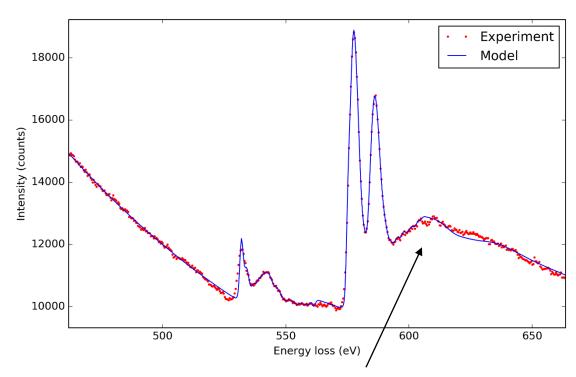


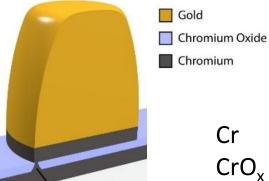


# Plasmon induced conductive filament in CrO<sub>x</sub>











3.0 2.7

2.4 2.1

1.8

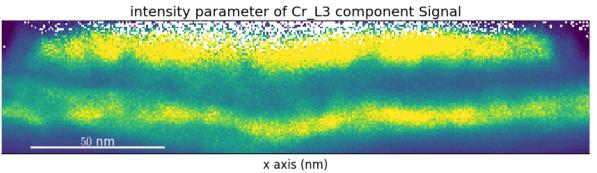
1.5

1.2

0.9

0.6

0.3



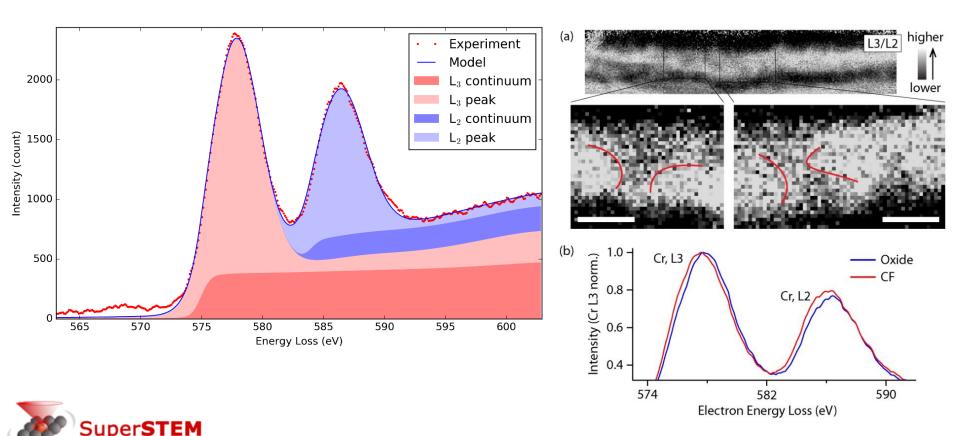


**Filament** 

Cr

### Curve fitting of white line

- The University of Manchester
- Convolution with low-loss to model plural scattering
- Hartree-Slater cross section to model continuum
- Gaussian function to model L<sub>3</sub> and L<sub>2</sub> peak
  - Data acquired with end-of-life X-FEG: energy resolution ~ 1.2 eV



### Curve fitting method



# **Advantage**

- Work well with overlapping edges
- Highly flexible
- Model plural scattering
- Model noise
- Error calculation
- Use all data points

#### **Drawback**

- Slow
- Complex
- Non-linear problem
  - convergence issue
  - Very sensitive to starting parameters



#### Reference

# The University of Manchester

# Integration method

- Transmission Electron Microscopy , Williams & Carter (2009) Springer, chapter 39
- Electron Energy-Loss Spectroscopy in the Electron Microscope, Egerton (2011) Springer

# Curve fitting method

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- Manoubi et al. (1990) Curve fitting methods for quantitative analysis in electron energy loss spectroscopy. Microscopy Microanalysis Microstructures, 1: 23
- Verbeeck and Aert (2004) Model based quantification of EELS spectra.
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